In re Appln. of Takayuki HISAKA Application No. Unassigned

ABSTRACT AMENDMENTS

Replace the Abstract with:

A semiconductor device includes a semiconductor substrate 10, a channel layer 7, a Schottky layer 5a, 5b, a first layer 12 having a narrower band gap than the Schottky layer, a second layer 11 having band discontinuity with the Schottky layer, a gate electrode 1, an n+ layer 4, a source electrode 2, and a drain electrode 3. The first and second layers are inserted in within the Schottky layer, and the second layer is disposed on the first layer.